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JUN 15 1999
GROUP 1700

IN THE CLAIMS

164. (Added) A method according to claim 129 wherein said composition comprises a substantially layered perovskite crystal structure.

165. (Added) A method according to claim 130 wherein said superconducting transistor metal oxide comprises a substantially layered perovskite crystal structure.

166. (Added) A method according to claim 131 wherein said superconducting copper oxide comprises a substantially layered perovskite crystal structure.

167. (Added) A method according to claim 132 wherein said superconducting oxide composition comprises a substantially layered perovskite crystal structure.

168. (Added) A method according to claim 133 wherein said superconducting oxide composition comprises a substantially layered perovskite crystal structure.

169. (Added) A method according to claim 134 wherein said transistor metal oxide comprises a substantially layered perovskite crystal structure.

170. (Added) A method according to claim 135 wherein said copper oxide comprises a substantially layered perovskite crystal structure.

171. (Added) A method according to claim 136 wherein said composition comprises a substantially layered perovskite crystal structure.

172. (Added) A method according to claim 137 wherein said composition of matter comprises a substantially layered perovskite crystal structure.

173. (Added) A method according to claim 138 wherein said composition of matter comprises substantially layered perovskite crystal structure.

174. (Added) A method according to claim 139 wherein said composition of matter comprises a substantially layered perovskite crystal structure.

175. (Added) A method according to claim 140 wherein said composition of matter comprises substantially layered perovskite crystal structure.